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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(211.001-D2-US)

In re Application of: **FAZAN ET AL.**

Serial No: **10/724,377**

Filing Date: **NOVEMBER 28, 2003**

Title: **SEMICONDUCTOR DEVICE**

) Group Art Unit:

) Examiner:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on July 29, 2004
Date

Michiko Siter
(person signing this certificate)

Michiko Siter
Signature

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THIRD PRELIMINARY AMENDMENT

Dear Sir:

Prior to the examination of the above-referenced application, kindly amend the application as follows: